Inventor(s): Lin, et al Serial No.: To Be Assigned Filed: Herewith

For: Direct Detection Of Dielectric Etch System ... Malfunctions Attorney Docket No.: 67,200-464

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## FIG 1A

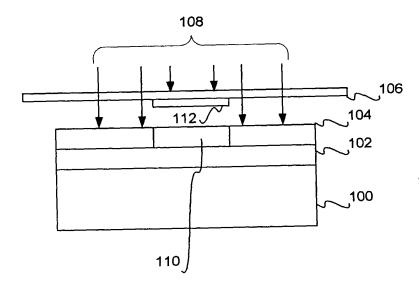
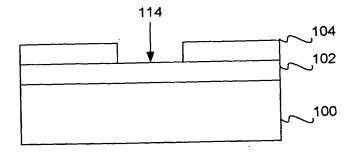


FIG 1B

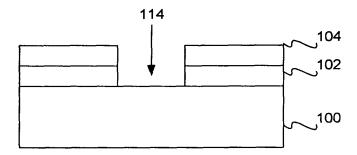


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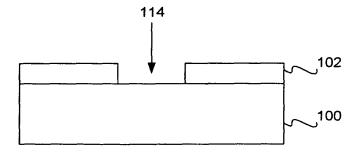
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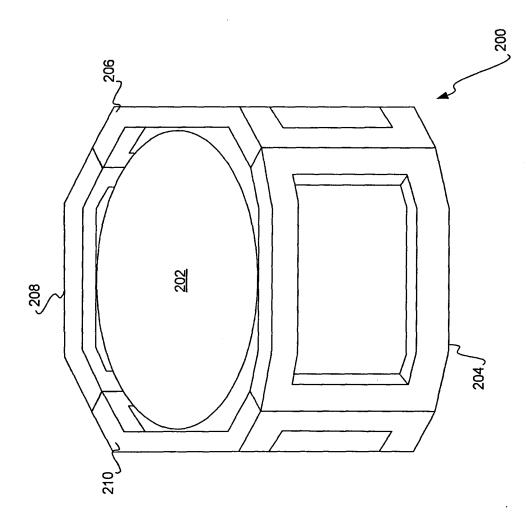
## FIG 1C



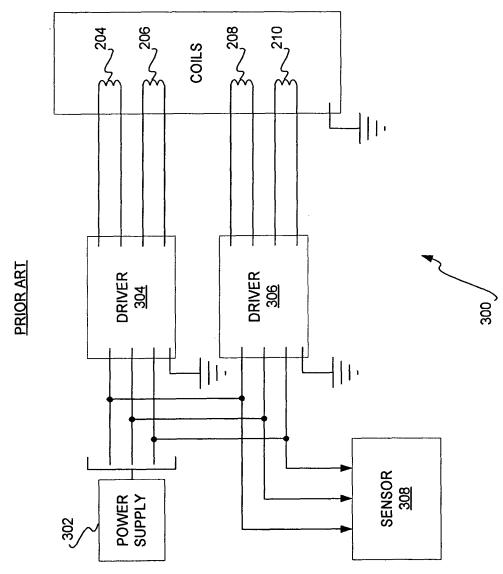
## FIG 1D



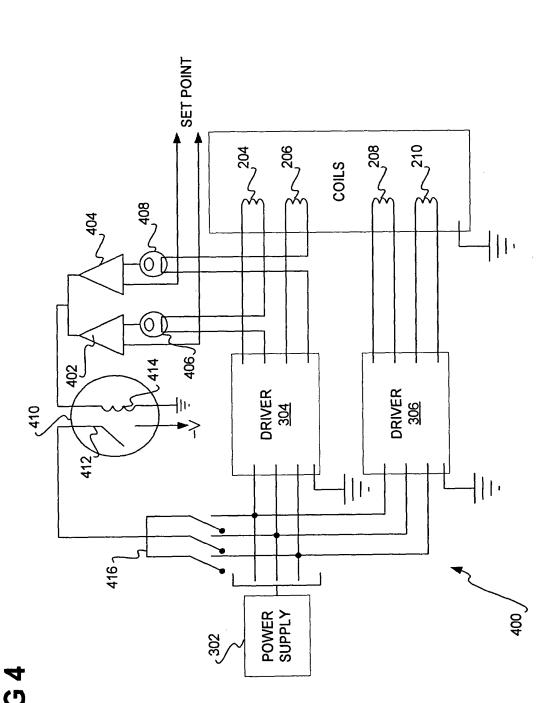
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